

Measurements of thin films on curved samples that are large, difficult to place on sample holder or to move (e.g. assemblies) require special probes. MP-FLVis manual probe has a soft rubber padding and can be placed directly on the product. It is connected to a measurement unit with fiberoptics cable.

BACKSIDE REFLECTION

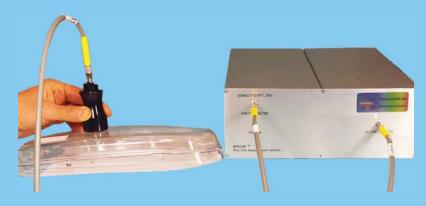
MP-FLVis probe is targeted for applications where film is deposited on relatively thin transparent substrate and there is a need to eliminate the backside reflection (e.g there may be coating on the backside).

Examples of such applications are hardcoat on eyeglass lenses, hardcoat or anti-fog coat on head/rear automotive lights (covers and lenses).

Ease of Use

One-click measurement and analysis. Automatic adjustment of integration time. Powerful software tools that correct and optimize measured data.

MProbe VisHC Thin Film Measurement System It is easy to be an expert with MProbe

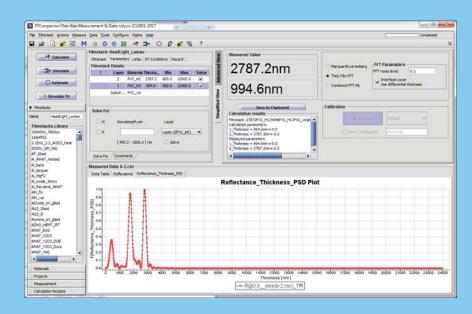


MProbeHC system

Precision	0.0 lnm or 0.01%
Accuracy	0.2% or 1 nm
Stability	0.02nm or 0.03%
Spot Size	0.2mm or 0.4mm (depending on fiber)
Sample Size	> 25mm
Thickness range	0.05 -70 μm

MProbe Advantage

- Standalone software included
- Remote diagnostics
- Dispay residual color
- Measurement history for recall and display (plots and statistics)
- Compare and evaluate multiple reflectance spectra
- Microprocessor controlled light source with 10000+ hours lifetime
- Free software update for 12 months

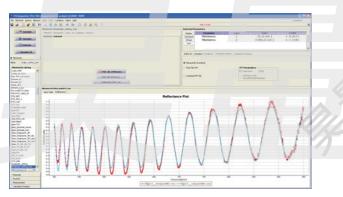


Hardcoat measurement. HC and IPL (interpenetration layer) thicknesses are determined

Specification

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Measurement of HC on rear-light (red) covers



Measurement of anti-fog coating on lens

Spectral range (nm)	400-1000	
Spectrometer/detector	F4 spectrometer, 3600 pixels Si CCD, 16 bit ADC, 380-1100 nm range	
Spectral resolution	<1 nm FWHM	
Light source	5 W Tungsten-halogen lamp (Xe filled), CT 2800° Lifetime: 10000 hrs	
Reflectance probe	Fiberoptics (7 fibers as- sembly), 400 µm fiber core	
Precision	<0.01 nm or 0.01%	
Accuracy	<1nm or 0.2%	
Weight (main unit)	5 kg	
Size (main unit)	8"x 12" x 4" (WxDxH)	
Power	100-250 VAC, 50/60 Hz 20 W	

	Hardware options	
- FO200	Using 200µm fiberoptics probe (for 0.2mm spot size)	
- 20W	Change to 20W (CT 3100°, lifetime 2000hrs) tungsten-halogen lamp. upgrade spectrometer for higher qual- ity photometric measurement.	
-AR1		
-AR2	upgrade spectrometer for highest qual- ity photometric measurement.	

Photometric specification						
	НС	HC-AR1	HC-AR2			
Wavelength accuracy	<0.5 nm	<0.5 nm	<0.5nm			
Wavelength Reproducibility	0.1nm	<0.1nm	<0.1nm			
Photometric Accuracy	0.01A	<0.005A	<0.001A			
Noise	0.001A rms	<0.0005A rms	<0.0001A rms			
Stray Light	0.05% at 600nm	<0.05% at 600 nm	<0.01% at 600nm			